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				Application Number	TBD
				Filing Date	Herewith
				First Named Inventor	Srinivasan Chakravarthi, et al.
				Group Art Unit	2813
				Examiner Name	Yennhu B. Huyh
Sheet	1	of	1	Attorney Docket No.	TI-33161.2

U.S. PATENT DOCUMENTS						
Exam. Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Doc.	Date of Pub. of Cited Doc. (mm-dd-yyyy)	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
	AA	6,037,640		Lee	3/14/00	
	AB					
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FOREIGN PATENT DOCUMENTS								
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Exam. Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	CA	P. PACKAN ET AL., "Modeling Solid Source Boron Diffusion for Advanced Transistor Applications" IEEE, IEDM 98, pp. 505-508	
	CB	DANIEL F. DOWNEY ET AL., "Effect of Fluorine on the Diffusion of Boron in Ion Implanted Si" 1998 American Institute of Physics, Vol. 73, Number 9, August 31, 1998, pp. 1263-1265	
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Examiner Signature	Date Considered
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